

RABIN & BERDO, P.C.

*Specializing in Patent, Trademark
And Copyright Law*

Steven M. Rabin
Robert H. Berdo, Jr.
Phillip G. Avruch
Allen Wood

Qixia Zhang, Pat. Agent (China)

Suite 500, 1101 14th Street, N.W.
Washington, D.C. 20005
Tel.: (202) 371-8976 Fax: (202) 408-0924
E-Mail: firm@rabinchamp.com

November 14, 2003

In Affiliation with
Weiss, Moy & Harris, PC
having offices in Arizona and Nevada,
and in Washington, DC with
Rabin & Berdo, PC

17497 U.S. PTO
10/712090



Box: PATENT APPLICATION

Commissioner for Patents
Washington, D.C. 20231

Attorney Reference: SAT 198

Re: New Patent Application of: Akio NAKAMURA

Title: SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD

Sir:

Please find attached hereto an application for patent which includes:

- [x] Specification, Claims and Abstract (32 Pages)
- [x] 19 Sheets of Formal Drawings (Fig. 1 through Fig. 32)
- [x] Inventor's Declaration and Power of Attorney (3 Pages)
- [x] Assignment document with cover page (2 Pages)
- [x] Claim for priority and the Priority document
- [x] Form PTO-2038
- [x] Fee (see formula below)

Basic Fee \$770/385 \$ 770.00

Additional Fees:

Total number of claims: 17
in excess of 20: 0 times \$18/9 \$ 0.00

Number of independent claims: 2
in excess of 3: 0 times \$86/43 \$ 0.00

Multiple Dependent Claims \$290/145 \$ 0.00

Recording Fee \$40. \$ 40.00

TOTAL FEES FOR THE ABOVE APPLICATION \$ **810.00**

In the event there is attached hereto no credit card form PTO-2038 or check, or there is an insufficient amount, please charge the fee to our Account No. 18-0002 and notify us accordingly.

The rights of priority are claimed under 35 USC §119 of Japanese Application No. 2002-000859, filed January 7, 2003.

Respectfully submitted,

Robert H. Berdo, Jr. (Reg. No. 38,075)
(Customer No. 23995)

November 14, 2003
Date
RHB:tz

13281 U.S. PTO



111403